

Title: Method of Processing Surface of Nitride Semiconductor Crystal and Nitride Semiconductor Crystal Obtained with the Method

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FIG.1

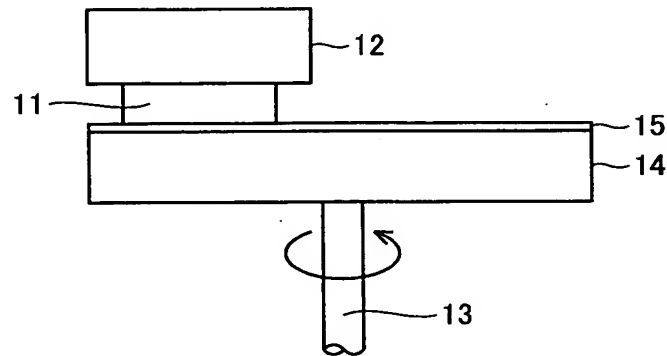


FIG.2

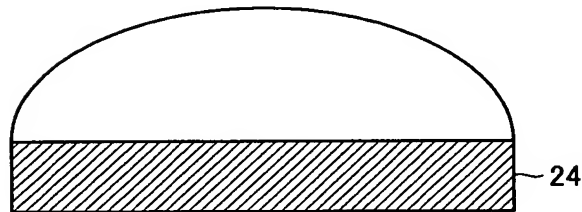


FIG.3

